FOR:

209294US2

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INVENTOR(S) Takahisa KIKUCHI

SERIAL NO: **New Application**

FILING DATE: Herewith

EVALUATION METHOD, POSITION DETECTION METHOD, EXPOSURE METHOD AND DEVICE

MANUFACTURING METHOD, AND EXPOSURE APPARATUS

FEE TRANSMITTAL

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

FOR	NUMBER FILED	NUMBER EXTRA	RATE	CALCULATIONS
TOTAL CLAIMS	19	× \$18 =	\$342.00	
INDEPENDENT CLAIMS	10 - 3 =	7	× \$80 =	\$560.00
□ MULTIPLE DEPENDE	\$0.00			
■ LATE FILING OF DEC		+ \$130 =	\$130.00	
BASIC FEE			\$710.00	
TOTAL OF ABOVE CALCULATIONS			\$1,742.00	
□ REDUCTION BY 50% FOR FILING BY SMALL ENTITY \$0.00				
■ FILING IN NON-ENGLISH LANGUAGE			+ \$130 =	\$130.00
□ RECORDATION OF ASSIGNMENT + \$40 =		+ \$40 =	\$0.00	
			TOTAL	\$1,872.00

Please charge Deposit Account No. 15-0030 in the amount of

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A check in the amount of

\$1,872.00

to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge any additional fees which may be required for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Date:

Marvin J. Spivak

Registration No.

ration No. 24,913 C. Irvin McClelland

Registration Number 21,124





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IN RE APPLICATION OF: Takahisa KIKUCHI

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SERIAL NO: New Application

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REQUEST FOR PRIORITY

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

- ☐ Full benefit of the filing date of U.S. Application Serial Number, filed, is claimed pursuant to the provisions of 35 U.S.C. §120.
- ☐ Full benefit of the filing date of U.S. Provisional Application Serial Number, filed, is claimed pursuant to the provisions of 35 U.S.C. §119(e).
- Applicants claim any right to priority from any earlier filed applications to which they may be entitled pursuant to the provisions of 35 U.S.C. §119, as noted below.

In the matter of the above-identified application for patent, notice is hereby given that the applicants claim as priority:

COUNTRY

APPLICATION NUMBER

MONTH/DAY/YEAR

JAPAN

2000-161323

May 31, 2000

JAPAN

2001-159388

May 28, 2001

Certified copies of the corresponding Convention Application(s)

- are submitted herewith
- will be submitted prior to payment of the Final Fee
- □ were filed in prior application Serial No. filed
- were submitted to the International Bureau in PCT Application Number.

 Receipt of the certified copies by the International Bureau in a timely manner under PCT Rule 17.1(a) has been acknowledged as evidenced by the attached PCT/IB/304.
- ☐ (A) Application Serial No.(s) were filed in prior application Serial No. filed ; and
 - (B) Application Serial No.(s)
 - are submitted herewith
 - □ will be submitted prior to payment of the Final Fee

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

Marvin J. Spivak

Registration No. C. Irvin McClelland

Registration Number 21,124



22850

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 10/98)

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IN RE APPLICATION OF: Takahisa KIKUCHI

SERIAL NO. NEW APPLICATION

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STATEMENT RE FILING IN FOREIGN LANGUAGE

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:	
ij	It is hereby stated that the subject application is being filed in a foreign language, in accordance with the provisions
of 37	CFR 1.52(d).
131	An accurate English translation, and a suitable amendment placing the application and claims thereof into proper
U.S.	format if needed, will be filed in due course.
- 124	
1 ===	Respectfully Submitted,
	OBLON, SPIVAK, McCLELLAND,
[4]	MAIER & NEUSTADT, P.C.
	Chan Market
14	10 mm 1 obligation

Marvin J. Spivak

Registration No. 24,913

C. Irvin McClelland Registration Number 21,124



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(OSMMN 10/98)

PATENT APPLICATION TRANSMITTAL TOT, naw nonprovisional applications under 37 CFR 1.53(b)) nly for naw

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209294US2 Attorney Docket No.

Takahisa KIKU First Inventor or Application Identifier

EVALUATION METHOD, POSITION DETECTION METHOD, EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, AND EXPOSURE APPARATUS

Assignee Name: Nikon Corporation

Assignee Address: 2-3, Marunouchi 3-chome, Chiyoda-ku, Tokyo, 100-8331 Japan

1			_		-	(- 10
÷,	APPLICATION ELEMENTS See MPEP chapter 600 concerning utility patent application contents	ADD	RE	SS TO:	Assistant Commissioner for Box Patent Application Washington, DC 20231	or Patents	9/8674
1	Fee Transmittal Form (e.g. PTO/SB/17) (Submit an original and a duplicate for fee processing)			ACCOM	PANYING APPLICATION	PARTS	5C
••	(Submit an onginal and a duplicate for fee processing)	7.		Assignme	ent Papers (cover sheet &	document(s)	
2.	■ Specification Total Sheets 106	8.		Application	on Data Sheet. See 37 CF	R 1.76	
	- oposines	9.		37 C.F.R.	. §3.73(b) Statement is an essignee)	Power of Att	torney
3	■ Drawing(s) (35 U.S.C. 113) Total Sheets 18	10.			ranslation Document (if a		
٠.	Brawning(e) (ee ereserve)	11.		Information Statemen	on Disclosure nt (IDS)/PTO-1449 □	Copies of ID Citations	s
4.	□ Oath or Declaration Total Pages	12.		Prelimina	ary Amendment		l
•	a. Newly executed (original or copy)	13.			Ivance Serial No. Postcard		
13	b. Copy from a prior application (37 C.F.R, §1.63(d))	14.		Certified (if foreign p	Copy of Priority Documen	t(s)	
	i. DELETION OF INVENTOR(S) Signed statement attached deleting inventor(s) named in the prior application, see 37 C.F.R. §1.63(d)(2) and 1.33(b).	15.		Applicant See 37 CF	t claims small entity status R 1.27	5.	
[15]T	□ CD-ROM or CD-R in duplicate, large table or Computer Program (<i>Appendix</i>)	16.		Other:	Notice of Priority, List of and Address, Statement Language	Inventor's Na Re Filing in I	me -oreign
· 6.	□ Nucleotide and/or Amino Acid Sequence Submission (if applicable, all necessary)	ł					
Ę	a. Computer Readable Form (CRF)						
i	b. Specification or Sequence Listing on:	ł					
	i. □ CD-ROM or CD-R (2 copies); or	ļ					
	ii. □ Paper	İ					
Ä	c. Statements verifying identity of above copies						
1 7.	If a CONTINUING APPLICATION, check appropriate box, and sur				ation below:		
<u>.</u>	☐ Continuation ☐ Divisional ☐ Continuation	-in-p	art	(CIP)	of prior application no.:		
	Prior application information: Examiner:				Group Art Unit:	alied under Boy A	1h is
For s cons whe	CONTINUATION OR DIVISIONAL APPS only: The entire disclosure of the pricedered a part of the accompanying continuation or divisional application and is a portion has been inadvertently omitted from the submitted application part	ior app s here s.	by ir	tion, from wh acorporated b	by reference. The incorporation of	can only be relie	ed upon
18	18. Amend the specification by inserting before the first line the sentence:						
	☐ This application is a ☐ Continuation ☐ Division ☐ Continuation-in-part (CIP)						
	of application Serial No. Filed on						
	Which was published in English						
	Which was not published in English	ial N	^		Filed		
	□ This application claims priority of provisional application Serial No. Filed						
19. CORRESPONDENCE ADDRESS							
22850 (703) 413-3000							
	FACSIMILE: (703) 413-2220						
_							

Name:	Marvin J. Spivak		Registration No.:	24,913
Signature:		Chm Way	Date:	5/3/101
Name:		C. Irvin McClelland	Registration No.:	

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■ LATE FILING OF DEC	■ LATE FILING OF DECLARATION			\$130.00
BASIC FEE				\$710.00
	\$1,742.00			
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LIST OF INVENTOR'S NAME AND ADDRESS

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:

Listed below is the name and address of the inventor for the above-identified patent application.

13	Takahisa KIKUCHI	Tokyo, JAPAN
A declar	ation containing all the necessa	ary information will be submitted at a later date.
		Respectfully Submitted,
		OBLON, SPIVAK, McCLELLAND,
		MAIER & NEUSTADT, P.C.
		John Wis Hared
	•	Marvin J. Spivak
		Registration No. 24,913

C. Irvin McClelland
Registration Number 21,124



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